

	Type	Hits	Search Text	DBs	Time Stamp
1	BRS	0	maskless adj lithographic adj pattern	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/21 10:57
133	BRS	2	"20050130351"	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/04/11 11:51
134	BRS	5101	exposure adj (cell cells)	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/04/11 12:01
135	BRS	18	((mask?less) (without near2 mask)) and exposure adj (cell cells)	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/04/11 12:01
136	BRS	16	("3932932" "4528072" "5169805" "5432999" "5577050" "5745673" "5818748").pn.	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/04/11 11:59
137	BRS	148	shutter adj (cell cells)	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/04/11 12:01
138	BRS	34	((mask?less) (without near2 mask)) and shutter adj (cell cells)	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/04/11 12:01
139	BRS	54252	(electron electrons cells cells) with (thick thickness)	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/05/30 08:20
140	BRS	11984	(electron electrons cells cells) with (thick thickness) same substrate	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/05/30 08:21

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141	BRS	168	(lithograph\$3) with (electron electrons cells cells) with (thick thickness) same substrate	US -PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/05/30 08:21
142	BRS	351	(lithograph\$3) same (electron electrons cells cells) with (thick thickness) same substrate	US -PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/05/30 08:21
143	BRS	259	(lithograph\$3) same (electron electrons cells cells) with (thick thickness) same substrate and mask	US -PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/05/30 08:21
144	BRS	238	(lithograph\$3) same (electron electrons cells cells) with (thick thickness) same substrate and mask and pattern	US -PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/05/30 08:21
145	BRS	85	(lithograph\$3) same (electron electrons cells cells) with (thick thickness) same substrate same (expos\$4) and mask and pattern	US -PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/05/30 08:22
146	BRS	2691	direct adj write	US -PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/05/30 08:37
147	BRS	306	direct adj write adj lithograph\$3	US -PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/05/30 08:38
148	BRS	120	direct adj write adj lithograph\$3 and x?ray	US -PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/05/30 08:39

	Type	Hits	Search Text	DBs	Time Stamp
149	BRS	35	direct adj write adj lithograph\$3 and SLV	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/05/30 08:38
150	BRS	35	direct adj write adj lithograph\$3 and SLV and RSC	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/05/30 08:39
151	BRS	186	direct adj write adj lithograph\$3 and radiation	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/05/30 08:39
152	BRS	81	direct adj write adj lithograph\$3 and radiation with (electron electrons cell cells)	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/05/30 08:40
153	BRS	57	direct adj write adj lithograph\$3 and radiation with (electron electrons cell cells) and x?ray	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/05/30 08:40